



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 7751

SERIAL NUMBER 10/759,194	FILING DATE 01/20/2004 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. SON-1908/DIV
-----------------------------	---------------------------------------	--------------	------------------------	----------------------------------------

APPLICANTS

Takeshi Nogami, Kanagawa, JAPAN;

Akira Yoshio, Tokyo, JAPAN;
Shuzo Sato, Kanagawa, JAPAN;

** CONTINUING DATA *****

This application is a DIV of 09/655,833 09/06/2000 PAT 6,693,036 *ok HJ*

** FOREIGN APPLICATIONS *****

JAPAN P11-253605 09/07/1999 *ok HJ*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/21/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	25	30	4
Examiner's Signature <i>[Signature]</i>	Initials <i>HJ</i>			

ADDRESS

23353
 RADER FISHMAN & GRAUER PLLC
 LION BUILDING
 1233 20TH STREET N.W., SUITE 501
 WASHINGTON, DC
 20036

TITLE

Method for producing semiconductor device, polishing apparatus, and polishing method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
------------	---------------------------------------------------------------------------------------	------------------------------------------------------------------------------------------------------------------------------------------------------